



Form 1449*	Atty. Docket No.: 303.648US1	Serial No. 09/484,303
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	Filing Date: January 18, 2000	Group: 2825

U.S. PATENT DOCUMENTS

**Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
NB	4,565,157✓	01/21/1986	Brors, D.L., et al.	118	719	03/29/83
NB	4,847,111✓	07/11/1989	Chow, Y.C., et al.	427	38	06/30/88
NB	5,084,412✓	01/28/1992	Nakasaki, Y.	437	189	10/01/90
NB	5,231,056✓	07/27/1993	Sandhu, G.S.	437	200	01/15/92
NB	5,654,245✓	08/05/1997	Allen, G.L.	438	629	03/23/93
NB	5,670,420✓	09/23/1997	Choi, K.K.	437	189	11/08/95
NB	5,763,953✓	06/09/1998	Iljima, T., et al.	257	762	01/18/96
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**Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation Yes No
NB	07078815✓	03/20/1995	Japan	H01L	21/3205	

OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

**Examiner Initial	
NB	Shacham-Diamond, Y., et al., "Copper electroless deposition technology for ultra-large-scale-intergration (ULSI) metallization", <u>Microelectronic Engineering</u> , NL, Vol. 33, No. 1, XP004054497, 47-58, (1997) ✓
NB	Stroud, P.T., et al., "Preferential deposition of silver induced by low energy gold ion implantation", <u>Thin Solid Films</u> , Switzerland, Vol. 9, No. 2, XP000993098, 273-281, (Feb. 1972) ✓

Examiner <u>Neal Bereznay</u>	Date Considered <u>3-22-03</u>
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*Substitute Disclosure Statement Form (PTO-1449)

**EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.